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**PATENT**  
**Attorney Docket 2344-738**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	)	
	)	
Ofer Sneh	)	Group Art Unit: 1762
	)	
Serial No.: 10/052,890	)	Examiner: Not Yet Assigned
	)	
Filed: October 19, 2001	)	
	)	
Title: PROCESS FOR TUNGSTEN SILICIDE	)	
ATOMIC LAYER DEPOSITION	)	

**PRELIMINARY AMENDMENT**

Mail Stop Non-Fee  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Introductory Comments:

This Supplemental Preliminary Amendment is submitted prior to examination on the merits.  
Entry of this amendment is respectfully requested.

Please amend the above-identified application as follows: